

Form PTO-1449

Information Disclosure Statement
By Applicant

Docket: 91-579.9

SN: 09/115,492

Applicant: Mark E. TUTTLE et al.

Filed: 7/14/98

Art Unit: 1734

U.S. PATENT DOCUMENTS

| Examiner's Initial | Patent Number | Date | Name | Class | Subclass | Filing Date If Appropriate |
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| RRK | 4,612,409 | 9/86 | Hamakawa et al. | 136 | 244 | |
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| RRK | RE 35746 | 3/98 | Lake | 429 | 127 | 1/93 |
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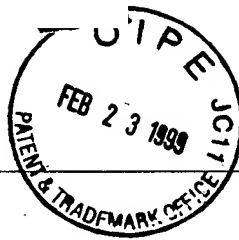
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| Examiner's Initial | Document Number | Date | Country | Class | Subclass | Translation Yes No |
|--------------------|-----------------|------|---------|-------|----------|-----------------------|
| RRK | 2-021557 | 1/90 | Japan | — | — | English Abstract only |
| RRK | 2-179794 | 7/90 | Japan | — | — | Partial |
| RRK | 4-106865 | 4/92 | Japan | — | — | English Abstract only |
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Examiner: *Dwight R. Koehler*

Date Considered: *May 7, 1999*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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| RRK | 4,942,327 | 7/90 | Watanabe et al. | 310 | 313. R | | |
| <hr/> | | | | | | | |
| Examiner: <i>Volker Koehler</i> | | | | Date Considered: <i>May 8, 1999</i> | | | |
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| OTHER DOCUMENTS | | | |
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| RRK | P. Ang; "Progress of QLF Barrier Coating"; Airco Coating Technology, Concord, CA. (Publication date not shown; mailed by Airco to Mark Tuttle 9/21/93.) | | |
| RRK | Untitled page stating moisture barrier performance of QLF barrier coating on 12μ polyester film, Sample ID # R9-930316. (Publication date not shown; mailed by Airco to Mark Tuttle 9/21/93.) | | |
| Examiner: | Date Considered: | | |
| John R. Koehler | | May 8, 1999 | |
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